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09/086700 09/086700

To: Honorable Commissioner of Patents and Trademarks:

Please record the attached original document(s) or copy thereof.

Name of conveying party(ies)
a) Calvin T. Gabriel

1. J. 2.

- 2. Name and address of receiving party(ies):
 - a) Name: VLSI Technology, Inc. Address: 1109 McKay Drive, San Jose, CA 95131
- 3. Nature of conveyance
 - X Assignment Security Agreement Other

Merger Change of Name

Execution Date: May 26, 1998

Application Number(s) or Patent Number(s): 09/0867004.

The title of the new application is: METHOD FOR REDUCING FACETING ON A PHOTORESIST LAYER DURING AN ETCH PROCESS

5. Please send all correspondence concerning this document to:

			Raymis H. Kim
/ 06/04/1998 DTHOMAS	00000064 09086700	HICKMAN & MARTINE, LLF	
		P.O. Box 52037	
		Palo Alto, CA 94306	
\ 03 FC:581	40	.00 OP	Tel. No.: (650) 470-7430
\mathbf{X}			Palo Alto, CA 94306 Tel. No.: (650) 470-7430 Fax No.: (650) 470-7440

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41): <u>\$40.00</u>

XEnclosedXIf there is any additional fee, the Examiner is authorized to
charge to Deposit Account No. 50-0384 (Order No. VTI1P203).

8. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Date: May 28, 1998

Raymis Kim Raymis H. Kim, Esq.

Raymis H. Kim, Esq. Registration No. 39,462

Attorney Docket No. VTI1P203

(Revised 01/96) PATENT REEL: 9224 FRAME: 0698

ASSIGNMENT OF PATENT APPLICATION

(Accompanying Application)

Whereas I the undersigned inventor have invented certain new and useful improvements as set for in the patent application entitled:

METHOD FOR REDUCING FACETING ON A PHOTORESIST LAYER DURING **AN ETCH PROCESS**

(Atty. Docket No.: VTI1P203) for which I have executed an application for a United States Letters Patent.

For good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, I the undersigned inventor hereby:

1) Sell(s), assign(s) and transfer(s) to VLSI Technology, Inc., a Delaware corporation having a place of business at 1109 McKay Drive, San Jose, CA 95131, (hereinafter referred to as "ASSIGNEE"), the entire right title and interest in any and all improvements and inventions disclosed in, application(s) based upon, and Patent(s) (including foreign patents) granted upon the information which is disclosed in the above referenced application.

2) Authorize and request the Commissioner of Patents to issue any and all Letters Patents resulting from said application or any division(s), continuation(s), substitutes(s) or reissue(s) thereof to the ASSIGNEE.

3) Agree to execute all papers and documents and, entirely at the ASSIGNEE's expense. perform any acts which are reasonably necessary in connection with the prosecution of said application, as well as any derivative and applications thereof, foreign applications based thereon, and/or the enforcement of patents resulting from such applications.

Agree that the terms, covenants and conditions of this assignment shall inure to the 4) benefit of the Assignee, its successors, assigns and other legal representative, and shall be binding upon the inventor, as well as the inventor's heirs, legal representatives and assigns.

5) Warrant and represent that I have not entered, and will not enter into any assignment. contract, or understanding that conflicts with this assignment.

Signed on the date indicated beside my signature.

1) Signature: Typed Name:

Cal' T. Jsch Date: 5/26/57 Calvin T. Gabriel

Attorney Docket No. VTI1P203

RECORDED: 05/28/1998